

S/N 10/ 720,409

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confirmation no. 5057

Applicant Feng Chen

Attorney Docket: CS03-039

Submission with RCE and Response to Advisory action dated 2006-12-14

To: Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: William J. Stoffel  
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Subject:

S/N 10/ 720,409  
Inventor Feng Chen  
Confirmation no. 5057  
Attorney Docket: CS03-039

File date: 11/24/2003

**Title : CMP Polishing Heads Retaining Ring Groove Design for Microscratch Reduction**

Group Art Unit: 3723  
Examiner: Shakeri

**SUBMISSION REQUIRED UNDER 37 CFR 1.114  
SUBMISSION WITH RCE -**

Dear Sir:

Enclosed is a Response to the Advisory Action dated 2006-12-14 and to the final Office Action dated 2006-09-25. Please consider the following remarks:

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION  
Total 26 Pages**

I hereby certify that this correspondence is being :

[ ☐ ] FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-8300 or

[ ☐ ] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.

Signature William J. Stoffel/ DATE Feb 24, 2007

William J. Stoffel

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**This response to Office Action has the following sections:**

- **AMENDMENTS TO THE CLAIMS** are reflected in the listing of claims that begin on the next page (p. 3)
- **REMARKS/ARGUMENTS** begin on the page following the previous section (p. 10)